Application/Control No.	Applicant(s)/Patent under Reexamination		
10/719,539	LIN ET AL.		
Examiner	Art Unit		
Tan V Mai	2193		

SEARCHED					
Class	Subclass	Date	Examiner		
update	search	10/1/2007	MAI		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
interferen	search (see ce search tout)	10/1/2007	MAI	

SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
updated search (see search history printout(s))	10/1/2007	MAI